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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of: Takeshi  
Nogami, et al.

Application No. 10/775,935

Filed: February 10, 2004

For: SEMICONDUCTOR  
MANUFACTURING APPARATUS AND  
METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICES

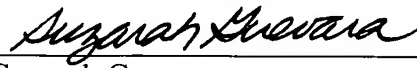
Group Art Unit: To be assigned

Examiner: To be assigned

**CERTIFICATE OF MAILING**

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Suzarah Guevara

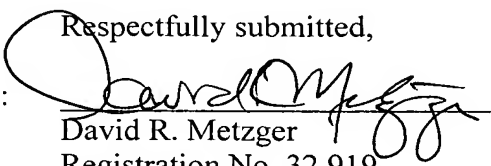
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**STATUS INQUIRY**

Sir:

With regard to the above-identified patent application that was filed in the U.S. Patent and Trademark Office on February 10, 2004, U.S. Serial No. 10/775,935, we have not yet received any communication from the U.S. Patent Office since issuance of the Filing Receipt which was dated May 7, 2004. At this time, we respectfully request the current status of this application.

Dated: December 2, 2005

Respectfully submitted,  
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